IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JAN 2 3 200

In re Patent Application of: Garry A. Mercaldi, et al.

Application No.: 09/285,773

Filed: April 5, 1999

For: METHOD FOR ETCHING DOPENDENA

POLYSILICON WITH HIGH SELECTIVITY TO UNDOPED

POLYSILICON

Group Art Unit: 1765

Examiner: L. Eronini

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AMENDMENT UNDER 37 CFR 1.116

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Assistant Commissioner for Patents Washington, DC 20231

Dear Sir:

In response to the Office Action dated October 23, 2000 (Paper No. 9), finally rejecting claims 1-7, 9-11, 13-18, 22-41 and 82-86, please amend the above-identified U.S. Patent application as follows:

IN THE CLAIMS:

Please amend the following claims:

1. (Twice Amended) A composition for selectively etching a doped substance,

and composition consisting essentially of:

a non-aqueous composition of an alcohol and at least two inorganic acids[, wherein a major component of said composition is non-aqueous].